

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/615,926 Confirmation No. : 9914

First Named Inventor : Hideaki YAMASAKI

Filed : July 10, 2003

TC/A.U. : 1792

Examiner : Jeffrie. R. LUND

Docket No. : 010986.52578US

Customer No. : 23911

Title : Film-Formation Apparatus and Source Supplying
Apparatus Therefor, Gas Concentration Measuring Method

REPLY

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated September 19, 2008. **An extension of the deadline for response to the Office Action is respectfully requested pursuant to 37 C.F.R. § 1.136(a) and the appropriate fee is submitted herewith.**

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **No additional claims fees are due.**

Remarks begin on page 12 of this paper.